



IPW

S&H Form: (2/01)  
Attorney Docket No. 1572.1246

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Jin-Seok LEE, et al.

Application No.: 10/811,896

Group Art Unit: 1765

Confirmation No.: 1334

Filed: March 30, 2004

Examiner: VINH, Lan

For: ETCHING APPARATUS AND METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement mailed February 13, 2006, Applicants elect claims 1-20 of Group I, without traverse.

Respectfully submitted,

STAAS & HALSEY LLP

Date: March 10, 2006

By:

Paul W. Bobowiec

Paul W. Bobowiec

Registration No. 47,431

1201 New York Ave, N.W., 7th Floor  
Washington, D.C. 20005  
Telephone: (202) 434-1500  
Facsimile: (202) 434-1501